

Paper and Other Web Coating Industry – 40 CFR Part 63, Subpart JJJJ Example Semi-Annual Report – Emission Monitoring System Performance (63.3400(c)) (For Facilities Demonstrating Compliance With Use of Capture/Control Equipment)			
Company Name:		Beginning date of reporting period:	Ending date of reporting period:
Name of Affected Source:		Address of Affected Source:	
Person to Contact Regarding Submittal:		Mailing Address:	Telephone No:
Brief description of process units:		Total operating time of affected source during reporting period:	
Identification of each hazardous air pollutant monitored at the affected source: 40 CFR Part 63 Subpart JJJJ regulates all organic hazardous air pollutant (HAP) emissions as a whole and does not regulate specific HAPs on an individual basis. Therefore, the identification of each hazardous air pollutant monitored at the affected source, as required by §63.10(e)(3)(vi) is the entire list of all of the organic HAP's. (Section 112(b)(1))			
Name, Title and Signature of Responsible Official Who is Certifying Accuracy of Report: I certify under penalty of law that I have personally examined and am familiar with the information submitted in this and all attached documents, and that based on my inquiry of those individuals immediately responsible for obtaining the information, I believe that the submitted information is true, accurate and complete. I am aware that there are significant penalties for submitting false information, including the possibility of fine and imprisonment. (63.3400(c)(2)(ii))			
Signature:			Date of report:
Printed Name:		Title:	
Deviations of Criteria ⁴			
Criteria Reviewed	Emission and operating parameter limitations specified in the relevant standard(s) for existing sources	Has standard been deviated from? The following character may used for convenience: <input checked="" type="checkbox"/>	Method of Compliance Determination. Check which applies. Only check if the relevant standard has been deviated from, then continue to next page. The following character may used for convenience: <input checked="" type="checkbox"/>
§63.3370 ⁵ (Check all compliance methods used)	Standard for Paper and Other Web Coating Facility ⁶		
§63.3370(e) <input type="checkbox"/> Permit Condition ⁷ :	Capture and control overall organic HAP emissions by 95%, or limit outlet organic HAP concentration < 20 ppmv by compound on a dry basis	<input type="checkbox"/> Yes <input type="checkbox"/> No	Continuous Parameter Monitoring System <input type="checkbox"/> Continuous Emissions Monitoring System <input type="checkbox"/> Solvent Recovery Liquid-Liquid Material Balance <input type="checkbox"/>
§63.3370(f) <input type="checkbox"/> Permit Condition:	Capture and control emissions to <0.2 kg organic HAP/kg solids as applied	<input type="checkbox"/> Yes <input type="checkbox"/> No	Continuous Parameter Monitoring System <input type="checkbox"/> Continuous Emissions Monitoring System <input type="checkbox"/> Solvent Recovery Liquid-Liquid Material Balance <input type="checkbox"/>
§63.3370(g) <input type="checkbox"/> Permit Condition:	Capture and control emissions to <0.04 kg organic HAP/kg coating material applied	<input type="checkbox"/> Yes <input type="checkbox"/> No	Continuous Parameter Monitoring System <input type="checkbox"/> Continuous Emissions Monitoring System <input type="checkbox"/> Solvent Recovery Liquid-Liquid Material Balance <input type="checkbox"/>
§63.3370(h) <input type="checkbox"/> Permit Condition:	Capture and control emissions to achieve allowable emissions rate calculated equivalent allowable organic HAP per §63.3370(l)	<input type="checkbox"/> Yes <input type="checkbox"/> No	Continuous Parameter Monitoring System <input type="checkbox"/> Continuous Emissions Monitoring System <input type="checkbox"/> Solvent Recovery Liquid-Liquid Material Balance <input type="checkbox"/>

⁴ If no exceedances or deviations occurred, complete only page 1 and submit to the appropriate agencies.

⁵ Note that multiple compliance methods may be used during the six-month period. If more than one method was used, identify in the box the month(s) when each particular compliance method was used. For reporting due dates, see the POWC Timeline.

⁶ A brief description of each potential compliance method (§63.3370(e) - (h)) is included. Please refer to the Standard for detailed descriptions of each method of compliance.

⁷ For Title V sources, enter the appropriate permit condition number

Deviation of Criteria: Applicable for Continuous Emissions Monitoring Systems (63.3400(c)(2)(vi))									
Identify deviation	Period of Malfunction (Start Date-Time, End Date-Time)	Date and Time CEMS and CPMS, if applicable, was inoperable⁸	Date and Time CEMS and CPMS, if applicable, was out of control	Total Hours of Deviation and Percent of Total Operating Hours	Breakdown of the Total Duration of the Deviation During the Reporting Period	Total Hours of CEMS and CPMS Downtime and Percent of Total Operating Hours	Breakdown of the Total Duration of CEMS and CPMS Downtime during the Reporting Period	Date of Latest CEMS and CPMS Certification or Audit	Describe any Changes in CEMS, CPMS, or Controls since Last Reporting Period
					Start-up: Shutdown: Control Equip Problems: Process Equip Problems: Other Known Causes: Other Unknown Cause:		Monitoring equipment malfunctions: Non-monitoring equipment malfunctions: QA/QC calibrations: Other Known Causes: Other Unknown Cause:		
					Start-up: Shutdown: Control Equip Problems: Process Equip Problems: Other Known Causes: Other Unknown Cause:		Monitoring equipment malfunctions: Non-monitoring equipment malfunctions: QA/QC calibrations: Other Known Causes: Other Unknown Cause:		
					Start-up: Shutdown: Control Equip Problems: Process Equip Problems: Other Known Causes: Other Unknown Cause:		Monitoring equipment malfunctions: Non-monitoring equipment malfunctions: QA/QC calibrations: Other Known Causes: Other Unknown Cause:		
					Start-up: Shutdown: Control Equip Problems: Process Equip Problems: Other Known Causes: Other Unknown Cause:		Monitoring equipment malfunctions: Non-monitoring equipment malfunctions: QA/QC calibrations: Other Known Causes: Other Unknown Cause:		
					Start-up: Shutdown: Control Equip Problems: Process Equip Problems: Other Known Causes: Other Unknown Cause:		Monitoring equipment malfunctions: Non-monitoring equipment malfunctions: QA/QC calibrations: Other Known Causes: Other Unknown Cause:		
					Start-up: Shutdown: Control Equip Problems: Process Equip Problemst: Other Known Causes: Other Unknown Cause:		Monitoring equipment malfunctions: Non-monitoring equipment malfunctions: QA/QC calibrations: Other Known Causes: Other Unknown Cause:		

⁸ Do not include downtime associated with zero (low-level) and high-level checks

Credits: This document was made possible through the efforts of the POWC Implementation Tool Development Partnership effort, an effort to bring together the regulated and regulatory community. It was through a group effort that this document was developed. The logo of the partner who was the lead for this tool is listed first below. To see a description of our partners or to get more information about the partnership effort, see <http://www.epa.gov/ttn/atw/powc/powcpg.html>

